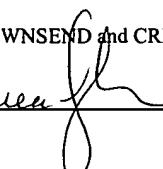


I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Assistant Commissioner for Patents  
Washington, D.C. 20231

On July 10, 2000

TOWNSEND and TOWNSEND and CREW LLP

By: 

**PATENT**  
Attorney Docket No.: 16301-021300US  
Client Reference No.: AM2119/PCT

#15  
7/18/00  
MW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Karl Littau et al.

Application No.: 08/893,917

Filed: July 11, 1997

For: REMOTE PLASMA CLEANING  
SOURCE HAVING REDUCED  
REACTIVITY WITH A SUBSTRATE  
PROCESSING CHAMBER

Examiner: Rudy Zervigon

Art Unit: 1763

**PETITION TO EXTEND TIME**

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Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant petitions the Assistant Commissioner of Patents to extend the time for response to the Office Action dated March 10, 2000 for 1 month, from June 10, 2000 to July 10, 2000. An appropriate response in the form of a Response to Advisory Action is enclosed herewith.

Please charge the fee of \$110.00 to the undersigned's Deposit Account No. 20-1430. Please charge any additional fees or credit overpayment to the above deposit account. This petition is submitted in triplicate.

Respectfully submitted,



Chun-Pok Leung  
Reg. No. 41,405

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